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Modeling of Rotational Motion of Carbon Nanotubes for Intelligent Manufacturing of CNT-Based Devices
 3.2.3 Dynamic Effect of Fluid Medium on Nano Particles by Dielectrophoresis 3.3 Theory for Microelectrode and Electric Field Design for Carbon Nanotube Applications 3.3.1 Microelectrode Design; 3.3.2 Theory for Microelectrode Design; 3.4 Electric Field Design; 3.5 Carbon Nanotubes Application -Simulation Results; 3.5.1 Dielectrophoretic Force: Simulation Results; 3.5.2 Electrorotation (Torque): Simulation Results; 3.5.3 Rotational Motion of Carbon Nanotubes: Simulation Results; 3.6 Summary; References; Chapter 4. Atomic Force Microscope-Based Nanorobotic System for Nanoassembly 4.1 Introduction to AFM and Nanomanipulation 4.1.1 AFM's Basic Principle; 4.1.2 Imaging Mode of AFM; 4.1.3 AFM-Based Nanomanipulation; 4.2 AFM-Based Augmented Reality System; 4.2.1 Principle for 3D Nanoforce Feedback; 4.2.2 Principle for Real-Time Visual Feedback Generation; 4.2.3 Experimental Testing and Discussion; A. Nanomanipulation with Augmented Reality System; B. Discussion: Limitations of Augmented Reality System; 4.3 Augmented Reality System Enhanced by Local Scan; 4.3.1 Local Scan Mechanism for Nanoparticle; 4.3.2 Local Scan Mechanism for Nanorod 4.3.3 Nanomanipulation with Local Enhanced Augmented Reality System A. Manipulation of Nanoparticles; B. Manipulation of Nanorods; 4.4 CAD-Guided Automated Nanoassembly; 4.5 Modeling of Nanoenvironments; 4.6 Automated Manipulation of CNT; 4.7 Summary; References; Chapter 5. On-Chip Band Gap Engineering of Carbon Nanotubes; 5.1 Introduction; 5.2 Quantum Electron Transport Model; 5.2.1 Nonequilibrium Green's Functions; 5.2.2 Poisson's Equation and Self-Consistent Algorithm; 5.3 Electrical Breakdown Controller of a CNT; 5.3.1 Extended Kalman Filter for Fault Detection 5.4 Effects of CNT Breakdown

Sommario/riassunto

Nanophotonics has emerged as a major technology and applications domain, exploiting the interaction of light-emitting and light-sensing nanostructured materials. These devices are lightweight, highly efficient, low on power consumption, and are cost effective to produce. The authors of this book have been involved in pioneering work in manufacturing photonic devices from carbon nanotube (CNT) nanowires and provide a series of practical guidelines for their design and manufacture, using processes such as nano-robotic manipulation and assembly methods. They also introduce the design and opera